



ATTORNEY'S DOCKET NO: S1022.80704US00

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants: Didier DUTARTRE and Patrick JERIER
Serial No: 09/902,497
Filed: July 10, 2001
For: METHOD OF EPITAXY ON A SILICON SUBSTRATE COMPRISING AREAS HEAVILY DOPED WITH ARSENIC

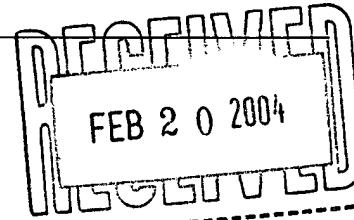
Examiner: Matthew A. Anderson
Art Unit: 1765 Confirmation No.: 7314

CERTIFICATE OF MAILING UNDER 37 C.F.R. §1.8(a)

The undersigned hereby certifies that this document is being placed in the United States mail with first-class postage attached, addressed to Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on February 9, 2004.

Eileen MacKenzie
Eileen MacKenzie

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450



Sir:

PETITION FOR THREE MONTH EXTENSION OF TIME

A three (3) month extension of time, to and including February 8, 2004, is requested for response to the Patent Office Communication of August 8, 2003. Since February 8, 2004 fell on a Saturday, this response is considered timely filed.

The extension fee of \$950.00 as set forth in 37 C.F.R. §1.17(a) is enclosed herewith. If the amount is insufficient, the balance may be charged to Deposit Account No. 23/2825.

Respectfully submitted,

Didier DUTARTRE and Patrick
JERIER

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